

Supplementary Table S1: Detailed instrumentation of GC/MS profiling.

Instrument	Agilent
Column	HP-5 _{MS}
Experimental condition	
Inlet temperature	250°C
Injection mode	Split (1:5)
Carrier gas	Helium
Oven	
Initial temperature	50°C for 2 min
Ramp	10°C/min. to 200°C for 5 min, 5°C/min. to 250°C for 10 min.
Final temperature	250°C hold for 10 min.
Injection	
Injection temperature	250°C
Split flow	7.5 ml/min.
Auxillary temperature	250°C
Detector	
Type	MS
Detector interface temperature	250°C
Ionization	EI
Scan mode	Full scan, m/z 50-700